



**THE UNITED STATES PATENT AND TRADEMARK OFFICE**

<b>Applicant:</b>	Eiko Suzuki	<b>Examiner:</b>	Brian Q. Le
<b>Serial No.:</b>	09/828,003	<b>Art Unit:</b>	2623
<b>Filed:</b>	April 6, 2001	<b>Docket:</b>	14467
<b>For:</b>	ID RECOGNITION APPARATUS AND ID RECOGNITION SORTER SYSTEM FOR SEMICONDUCTOR WAFER	<b>Conf. No.:</b>	5196
		<b>Dated:</b>	November 22, 2005

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT PURSUANT TO 37 C.F.R. § 1.111**

Sir:

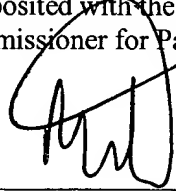
In response to the final Office Action dated June 22, 2005, Applicant respectfully requests under the provisions of 37 C.F.R. § 1.111 that the above-identified Application be amended as follows and that the Application be allowed.

---

**CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on November 22, 2005.

**Dated:** November 22, 2005

  
Richard J. Danyko